

INFORMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary)	Attorney Docket No.: 8006-1032	Application No.: 10/576,112
	Applicant: Akira UEMATSU	
	Filing Date: August 21, 2006	Group Art Unit: 2617

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing date (if appropriate)
	2004/0059689	2004-03-25	MUHONEN et al.			
	2004/0054598	2004-03-18	KALL et al.			
	7,418,256	2008-08-26	KALL et al.			

FOREIGN PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	Chinese Office Action in the corresponding Chinese patent application 200480037545.4, issued on October 24, 2008

EXAMINER: /Kuo-kong Woo/	DATE CONSIDERED 07/07/2009
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* Abstract provided for the Examiner's convenience

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /K.W./